



PATENT
03345-P0047A WWW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Markus Schwambera, et al.	
Serial No.: 10/754,817	Conf. No.:	Filing Date: January 9, 2004
Title of Application:	Process Chamber with a Base with Sectionally Different Rotational Drive and Layer Deposition Method in Such a Process Chamber	
Group Art Unit:	Examiner:	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

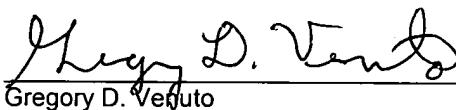
PRELIMINARY AMENDMENT

Dear Sir:

This Preliminary Amendment is being filed in connection with the above-identified patent application. Please enter this Preliminary Amendment before examining the application. Applicants believe that no fee is due in connection with the filing of this Preliminary Amendment. However, if any fee is due please charge Deposit Account No. 19-4516.

Certificate of Mailing: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner for Patents; P.O. Box 1450; Alexandria, VA 22313-1450.

February 6, 2004



Gregory D. Venuto